IE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Applicant:

Justin K. Brask et al.

Art Unit:

2811

Serial No.:

10/622,955

Examiner:

Sara W. Crane

Filed:

July 18, 2003

Atty Docket: ITL.1021US

P16708

For:

Etching Metal Silicides

and Germanides

Assignee:

Intel Corporation

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO PAPER NO. 052005

Sir:

In response to the office action mailed June 3, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: August 3, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1459)

Cynthia IJ. Hayden